



PATENT

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

APPLICANT: HENNHÖFER ET AL.
SERIAL NO.: 09/032,305 EXAMINER: R. KUNEMUND
FILED: FEBRUARY 27, 1998 GROUP: 1765
TITLE: PROCESS FOR TREATING A POLISHED SEMICONDUCTOR
WAFER IMMEDIATELY AFTER THE SEMICONDUCTOR WAFER
HAS BEEN POLISHED

RESPONSE TO FINAL OFFICE ACTION

MAIL STOP AFTER FINAL
Commissioner for Patents
P.O.BOX 1450
Alexandria, VA 22313-1450

Dear Sir:

This is in response to the Final Office Action dated
December 4, 2002, with the time for reply having been extended
for three months, from MARCH 4, 2003, until JUNE 4, 2003,
and with a Notice of Appeal and the Appeal Fee having been filed
and paid.

The Remarks begin on Page 2 of this document.